

Notice of References Cited	Application/Control No. 10/776,659	Applicant(s)/Patent Under Reexamination CHONG ET AL.	
	Examiner Li B. Zhen	Art Unit 2194	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-7,149,299	12-2006	Triano et al.	379/210.01
*	B	US-2003/0014461	01-2003	Tanaka, yasuoki	709/100
	C	US-			
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	F	US-			
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	I	US-			
	J	US-			
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	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

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	N					
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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